

Complete if Known

Application Number	10/004,572
Filing Date	December 4, 2001
First Named Inventor	BOESEN, DR. PETER V.
Art Unit	1. Douglas
Examiner Name	2834
Attorney Docket Number	P05420US0

(Use as many sheets as necessary)

Sheet 1 of 2

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Date	
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27-03

Applicant's unique citation designation number (optional).² See Kinds of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible.

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Substitute for form 1449B/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/009572
		Filing Date	December 4, 2001
		First Named Inventor	Boesen, Dr. Peter V.
		Group Art Unit	2834
		Examiner Name	T. Dougherty
		Attorney Docket Number	P05420US0
Sheet	2	of	2

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
TMY	1	MEASUREMENT SPECIALTIES, INC. "Piezo Film Sensors" Technical Manual, Apr 1999	
TMB	2	SANDIA NATIONAL LABORATORIES, Intelligent Micromachine Initiative, "Non-Inertial Sensors" Bibliography Table, 2001. 10/2001	
TMB	3	SANDIA NATIONAL LABORATORIES, "A New Analytical Solution For Diaphragm Deflection And Its Application To a Surface-Micromachined Pressure Sensor"; Wm. Eaton, F. Bitsi, J. Smith, D. Plummer 10/2001	
TMB	4	SANDIA NATIONAL LABORATORIES, Intelligent Micromachine Initiative "General Reviews" Bibliography Table, 2001 10/2001	
TMB	5	SANDIA NATIONAL LABORATORIES, Intelligent Micromachine Initiative, "Related WWW Links" 2001 10/2001	
TMB	6	SANDIA NATIONAL LABORATORIES, Intelligent Micromachine Initiative, "SUMMIT V Technology" 2001 10/2001	
TMB	7	SANDIA NATIONAL LABORATORIES, Intelligent Micromachine Initiative, "MEMS Overview" 2001 10/2001	
TMB	8	SANDIA NATIONAL LABORATORIES, Intelligent Micromachine Initiative, "SUMMIT Technology" 2001 10/2001	

Examiner Signature	<i>Therese Dougherty</i>	Date Considered	2-7-03
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* EXAMINER: Initial if reference considered whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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